

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Mitsuru SEKIGUCHI et al.)
Japanese Priority Application No. 2000-253794) Attn: Applications
Japanese Priority Date: August 24, 2000) Branch
For: SEMICONDUCTOR DEVICE AND)
METHOD FOR FABRICATING)
THE SAME) Date: August 8, 2001



INFORMATION DISCLOSURE STATEMENT

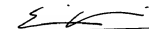
Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99,
it is requested that the reference listed on the attached Form PTO-1449 be made of
record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R.
1.98(a).

Respectfully submitted,


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